

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of
Lu

Appln. No. 09/838,316

Filed: 04/20/2001

Group Art: Unknown

Examiner: Unknown



RECEIVED

JAN 14 2002

TECHNOLOGY CENTER 2800

TITLE: METHOD FOR FABRICATING SILICON-ON-INSULATOR MATERIAL

PETITION TO ADD INVENTORS UNDER RULE 1.48(a)

Hon. Assistant Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

The above-identified application was filed under Rule 53 naming only Lu Zhiheng as the sole inventor. Luo Yan and Zhou Hongyu contributed to the subject matter of at least one claim and, therefore, should be named as co-inventors. The error of not naming the undersigned co-inventors occurred without deceptive intention on the part of each undersigned co-inventor.

We declare further that all statements made herein of our own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Yan Luo
Luo Yan

12-24-2001
Date

Hongyu Zhou
Zhou Hongyu

Dec-24-2001
Date